



# MPG Halbleiterlabor Review

## Saturday, 15 December 2018

### Technology discussion (09:00 - 10:40)

-Conveners: Alex Baehr

time	[id] title	presenter
09:00	[9] Lithography without DWLs	LEHMANN, Raik
09:20	[10] Lithography DWLs	BURKHARDT, Anne
09:40	[11] Wet Chemistry	JANSEN, Sven
10:00	[12] Ovens	ZIRR, Christian
10:20	[13] Implanter	MATIASKE, Mark

### Technology discussion: Technology discussion (11:00 - 12:30)

-Conveners: Jelena Ninkovic

time	[id] title	presenter
11:00	[14] Plasma Cluster(s)	SCHOPPER, Florian
11:20	[15] Cutters	MATIASKE, Mark
11:40	[16] New equipment plans	SCHOPPER, Florian
12:00	[17] Discussion QA	